

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent No. : 7,732,236
Application No. : 10/598,934
Issue Date : June 8, 2010
Inventors : Seiji Nakahata, Hideaki Nakahata, Koji Uematsu,
Makoto Kiyama, Youichi Nagai, Takao Nakamura
Docket No. : 039.0075
Customer No. : 29453

Honorable Commissioner for Patents
Office of Patent Publication
ATTN: Certificate of Correction Branch
P.O. Box 1450
Alexandria, VA 22313-1450

Request for Certificate of Correction **Pursuant to 37 C.F.R. § 1.322**

To the Corrections Branch Officer:

In the above-identified patent, Patentee requests that a Certificate of Correction be issued.

The text of Patentee's requested corrections is submitted on the accompanying Certificate of Correction form, PTO/SB/44.

The first of the requested corrections is to the title, which contains an error over the WIPO version in the publication of International App. No. PCT/JP2005/008745, the National Stage of which was App. No. 10/598,934, which issued as the instant patent.

The rest of the requested corrections are among the fourteen made to the specification in the preliminary amendment filed September 15, 2006 in App. No. 10/598,934, but of which only ten were successfully entered by the Office.

Hence, it is believed that the presently requested corrections are of errors attributable to the Office and of such a nature that the meaning intended is *not* obvious from the context.

Respectfully submitted,

August 23, 2010

/James Judge/

James W. Judge
Registration No. 42,701

JUDGE PATENT ASSOCIATES
Vert Nakanoshima Kita, Suite 503
6-3 Nishitemma 4-Chome, Kita-ku
Osaka-shi 530-0047
JAPAN

Telephone: **(305) 938-7119**
Voicemail/Fax: **(703) 997-4565**

UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

Page 1 of 1

PATENT NO. : 7,732,236

APPLICATION NO.: 10/598,934

ISSUE DATE : June 8, 2010

INVENTOR(S) : Seiji Nakahata, Hideaki Nakahata, Koji Uematsu, Makoto Kiyama, Youichi Nagai, Takao Nakamura

It is certified that an error appears or errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

In the title:

"III NITRIDE SEMICONDUCTOR DEVICE MANUFACTURING METHOD THEREOF"
should read --III NITRIDE SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD
THEREOF--

Column 11, lines 50 and 51, "10 μm " should read --10 $\mu\text{m/hr}$ --, and
lines 50 and 52, "300 μm " should read --300 $\mu\text{m/hr}$ --.

Column 20, lines 48 and 50,
"micro-apertures 2b," each occurrence, should read --micro-apertures 2s--.

Column 25, line 9, "10 μm " should read --100 μm --.

Column 54, line 55, " $\text{Al}_{0.25}\text{Ga}_{0.85}\text{N}$ " should read -- $\text{Al}_{0.25}\text{Ga}_{0.75}\text{N}$ --

MAILING ADDRESS OF SENDER (Please do not use customer number below):

This collection of information is required by 37 CFR 1.322, 1.323, and 1.324. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 1.0 hour to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. **SEND TO: Attention Certificate of Corrections Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.**

If you need assistance in completing the form, call 1-800-PTO-9199 and select option 2.